	Application No.	Applicant(s)	
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Notice of Allowability	10/630,716	FUKUYAMA ET AL.	
	Examiner	Art Unit	
	Stephen W. Smoot	2813	
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS nerewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIP of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate communication is supplication is supplication.	this application. If not included unication will be mailed in due course. THIS	
. X This communication is responsive to <u>applicant's amendme</u>	ent filed on 11 May 2005.		
2. X The allowed claim(s) is/are <u>5-7.</u>			
3. \boxtimes The drawings filed on <u>31 July 2003</u> are accepted by the Ex	kaminer.		
Acknowledgment is made of a claim for foreign priority ur a) ☑ All b) ☐ Some* c) ☐ None of the: 1. ☑ Certified copies of the priority documents have		or (f).	
2. Certified copies of the priority documents have	*	n No.	
3. Copies of the certified copies of the priority do	• •		
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requirements	
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			
6. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.		
(a) including changes required by the Notice of Draftspers	son's Patent Drawing Review	v (PTO-948) attached	
1) 🗌 hereto or 2) 🗍 to Paper No./Mail Date	٠	•	
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or	in the Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on the header according to 37 CF	ne drawings in the front (not the back) of R 1.121(d).	
 DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT 			
Attachment(s)			
1. Notice of References Cited (PTO-892)		formal Patent Application (PTO-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	Paper No.	 Interview Summary (PTO-413), Paper No./Mail Date Examiner's Amendment/Comment 	
B. Information Disclosure Statements (PTO-1449 or PTO/SB/0	08), 7. 🛭 Examiner's		
Paper No./Mail Date I. ☐ Examiner's Comment Regarding Requirement for Deposit	8. 🛭 Examiner's	Statement of Reasons for Allowance	
of Biological Material	9. 🗌 Other	_	
Steph	en W. Smoo	Stephen W. Smoot Patent Examiner Art Unit 2813	

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This Office action is in response to applicant's amendment filed on 11 May 2005, which has been entered.

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Per MPEP section 606.01, the title of the invention is being changed to more clearly indicate the invention in accordance with the allowed claims. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

In the Title: Change the title of the invention to --Semiconductor device using low-k material as interlayer insulating film and including a surface modifying layer--.

- 2. Claims 5-7 are allowed.
- 3. The following is an examiner's statement of reasons for allowance: Claims 5-7 are allowed because the prior art of record does not teach or suggest, in combination with the other claim limitations, a semiconductor device that includes a conductive

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connector that is buried in first and second insulating films for interconnecting a wiring pattern to a semiconductor element, with the second insulating film overlying the first insulating film and also having a lower dielectric constant than the first insulating film, wherein a surface modifying layer formed by using silane coupler or metal coupler is formed on an upper surface of the second insulating film and defines a trench bottom corresponding to the wiring pattern.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Stephen W. Smoot whose telephone number is 571-272-1698. The examiner can normally be reached on M-F (8:00 am to 4:30 pm).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead, Jr. can be reached on 571-272-1702. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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